

2822  
PATENT APPLICATION  
Docket No. 2522-013  
Client No. AW6028US/JS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Tae-Ho Jang Conf. No. 9968  
Serial No. 10/076,237 Examiner: Maria F. Guerrero  
Filed: February 13, 2002 Art Unit: 2822  
For: SILICON-ON-INSULATOR (SOI) SUBSTRATE AND METHOD  
MANUFACTURING THE SAME

Mail Stop NON FEE AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Responsive to the Office Action dated October 6, 2003, enclosed is an amendment in the above-identified application.

The fee has been calculated as shown below.

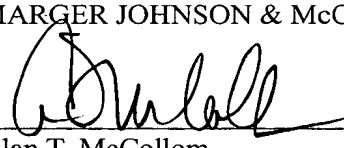
CLAIMS AS AMENDED					
For:	Number After Amendment	Previous Number	Extra	Rate	Additional Fee
Total Claims	19	18	0	x \$18 =	\$0.00
Independent Claims	3	3	0	x \$86 =	\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0.00

☒ Any deficiency or overpayment should be charged or credited to deposit account number 13-1703.

Customer No. 20575

Respectfully submitted,

MARGER JOHNSON & McCOLLOM, P.C.

  
Alan T. McCollom  
Reg. No. 28,881

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I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Non Fee Amendment Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450  
Date: January 5, 2004

  
Adrienne Chocholak